



IFW

Attorney Docket No. MXIC 1532-1

**CERTIFICATE OF MAILING**

I hereby certify that this correspondence is being deposited with the United States Postal Service as First Class Mail to: Mail Stop Amendment, Commissioner for Patents, Post Office Box 1450, Alexandria, Virginia 22313-1450 on November 2, 2004.

Paula Faulk Hurley  
Paula Faulk Hurley

***IN THE UNITED STATES PATENT AND TRADEMARK OFFICE***

In re application of: <b>Chih Yuan Huang</b> Application No.: <b>10/621,120</b> Confirmation No.: <b>1938</b> Filed: <b>July 16, 2003</b> Title: <b>Method of Forming Silicon Film with Changing Grain Size by Thermal Process</b>	Attorney Docket No.: MXIC 1532-1 Examiner: <b>Andy Huynh</b> Group: <b>2818</b>  Customer No. <b>22470</b>
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**RESPONSE A**

Mail Stop Amendment  
Commissioner for Patents  
Post Office Box 1450  
Alexandria, Virginia 22313-1450

Sir:

This RESPONSE A is in reply to the Office action mailed September 29, 2004. No fee is due.

**Amendments to the Claims** are reflected in the listing of claims which begins on page 2 of this paper.

**Remarks** begin on page 5 of this paper.